

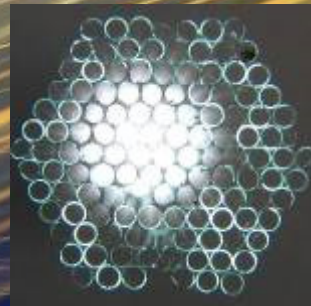
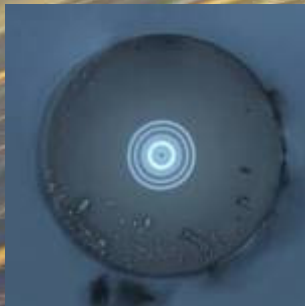


INTERNATIONAL
YEAR OF LIGHT
2015



Academy of Sciences
**Institute of Photonics and
Electronics v.v.i.**
Technology of Optical Fibers

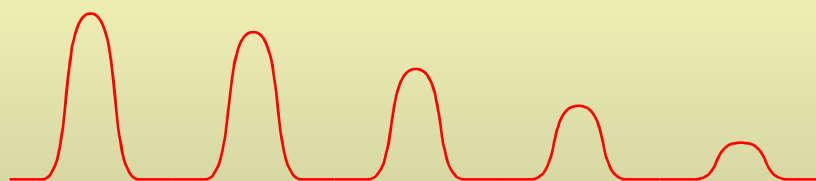
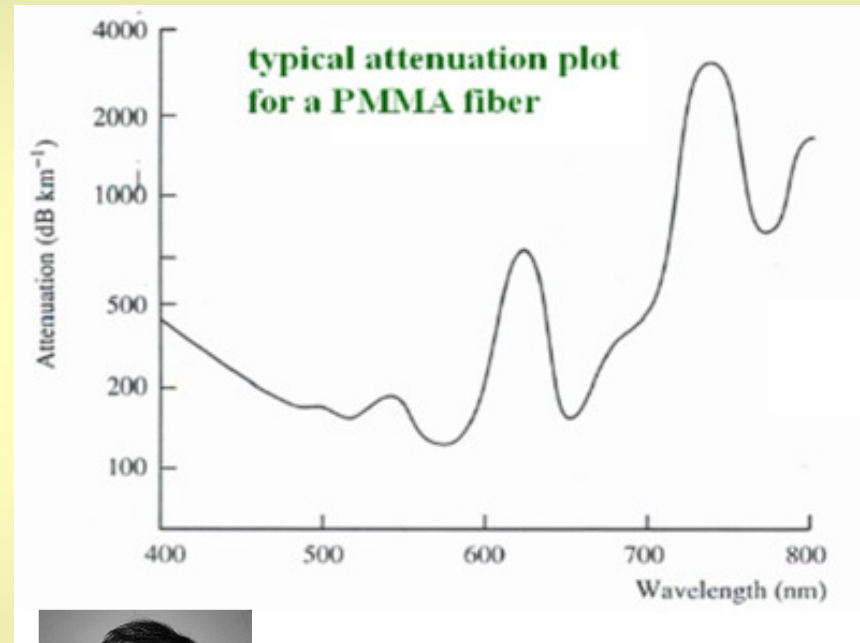
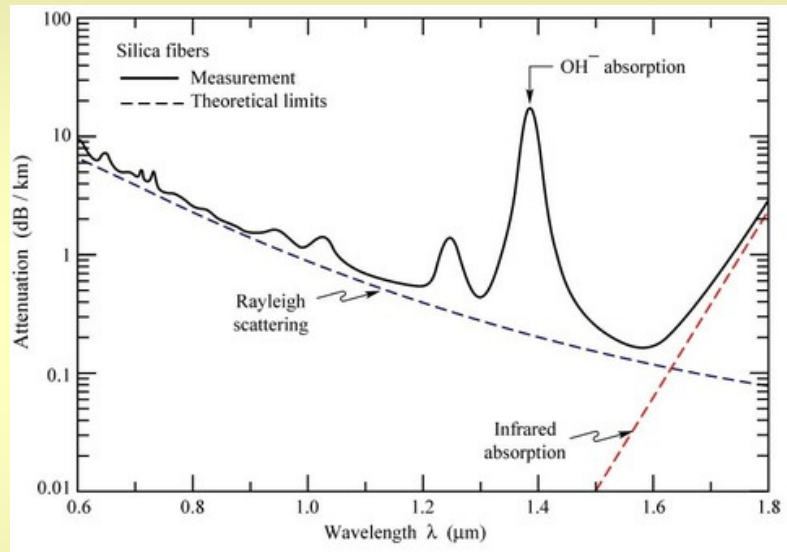
I.Kašík, www.ufe.cz



Optical fiber

Optical fiber : dielectric structure, $L \ll r$, $n_{\text{core}} > n_{\text{clad}}$

Optical losses in optical fibers (intrinsic, extrinsic)



attenuation, dispersion



Nobel prize
2009
Ch.K.Kao



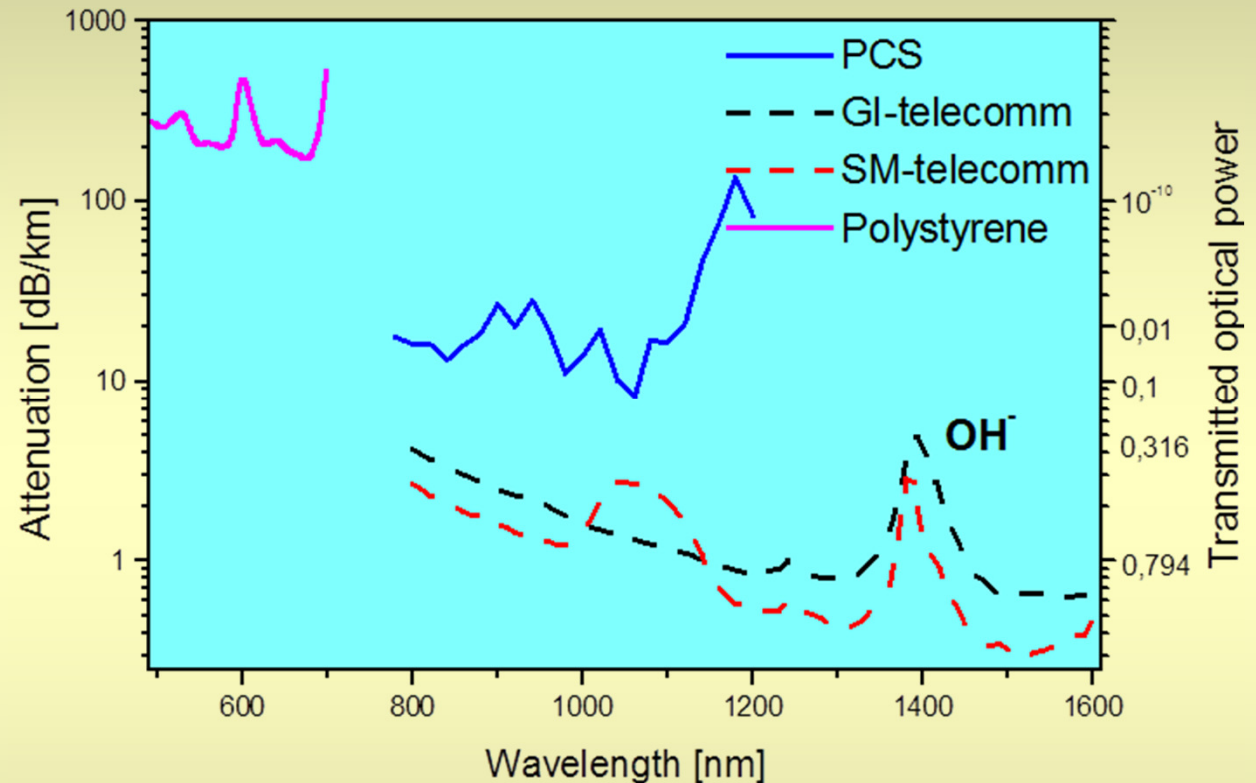
Optical fiber



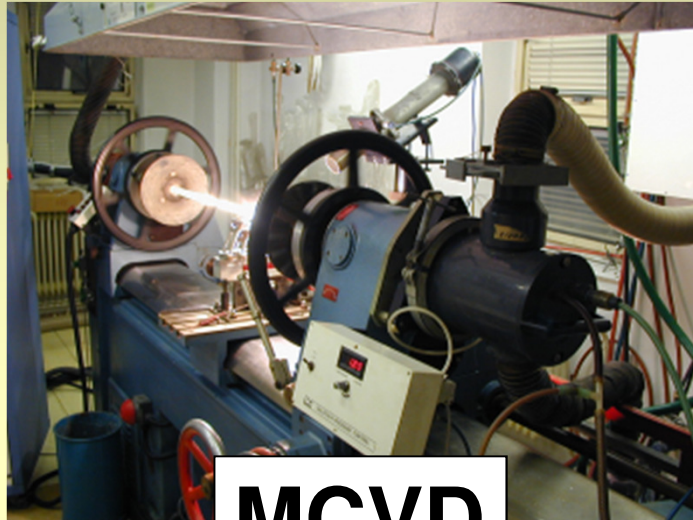
- high-purity
- silica based
materials,
max. impurities
acceptable in
ppb (10^{-9})



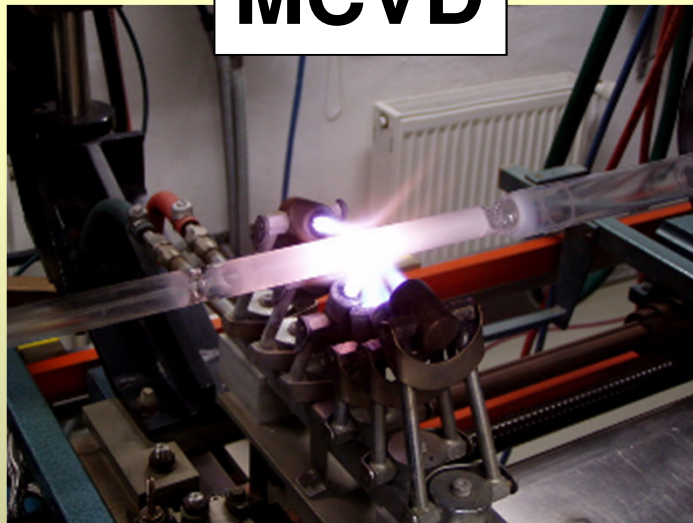
Conventional glassmaking =>
ULTRA-PURE TECHNOLOGIES



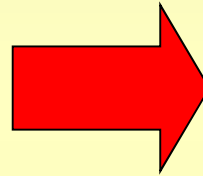
Optical fiber preparation



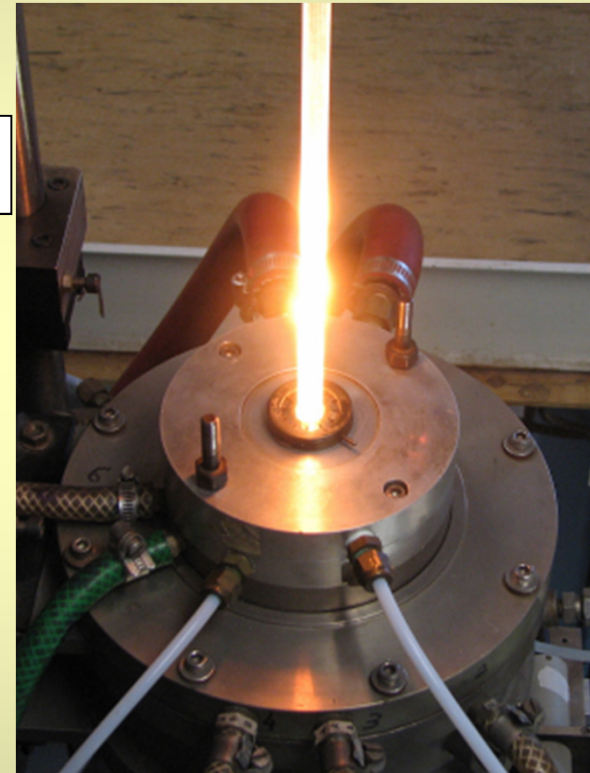
MCVD



1. Preform



2. Fiber drawing

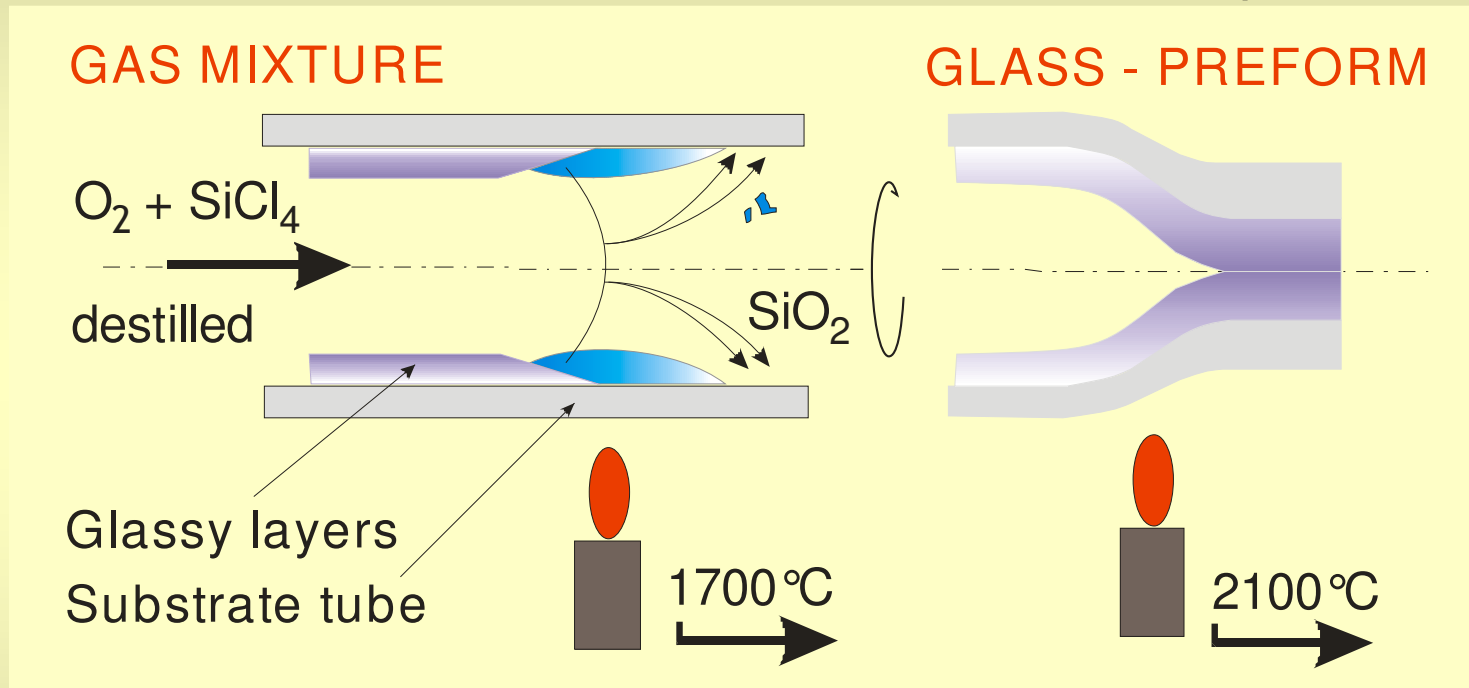


Preform preparation : CVD-based

MCVD – (Modified) Chemical Vapor Deposition

1. Deposition of layers

2. Collapse

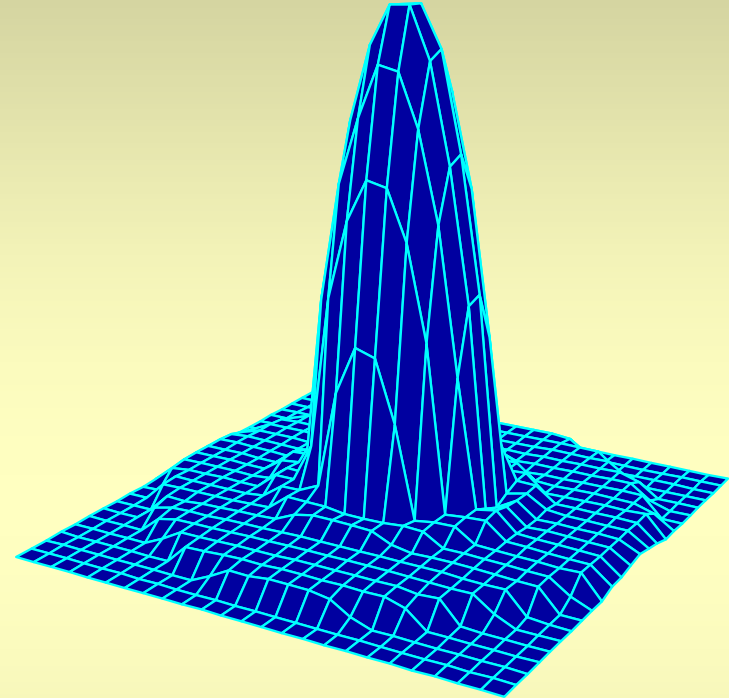


- Sequential sintering of **thin glassy layers** (of thickness 1-20 μm) onto inner wall of silica substrate **resulting in bulk material – preform**
- **high purity** ($\sim 10^1$ ppb) **high preciseness** (better than 1 %)

Preform



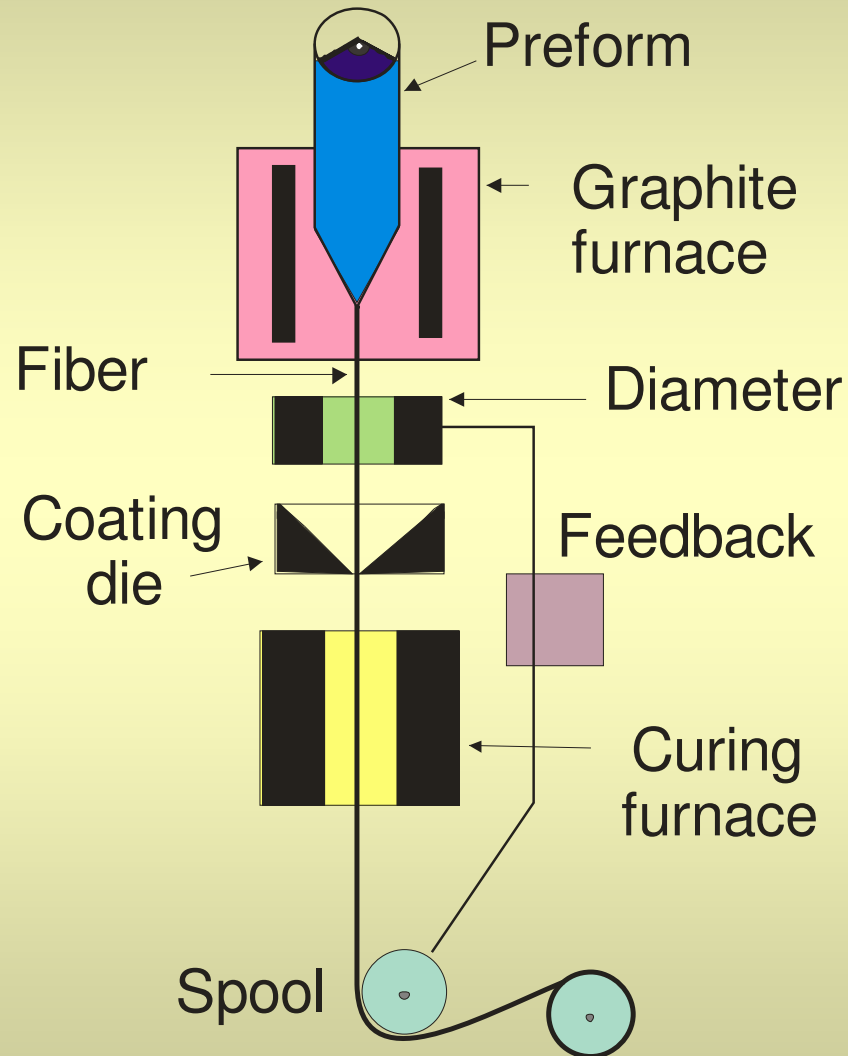
Microphoto of cross section
of produced preform



Tomography of the refractive-
index profile of preform

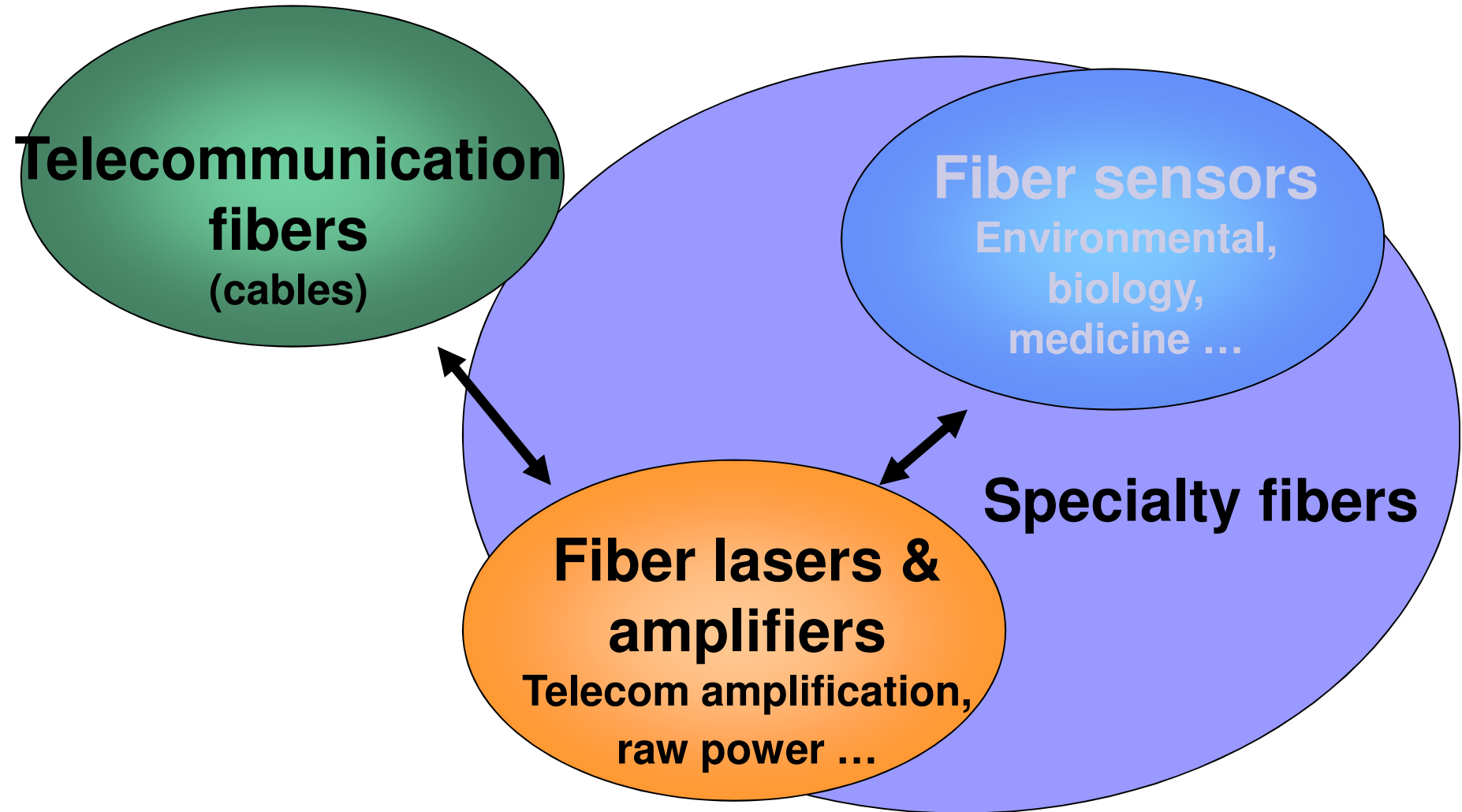
- High purity material due to FO-Optipur purity starting materials.
- High quenching rate ranging from 10^2 to 10^3 °C/s.

Drawing of optical fiber from preforms



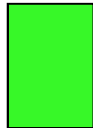
- Diameter
80-1000 μm
- Temperature
1800-2100 $^{\circ}\text{C}$
- No textile
- No thermo-insulation

Application

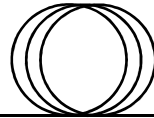


Telecommunications

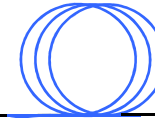
zdroj signálu



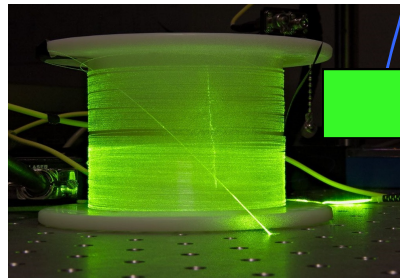
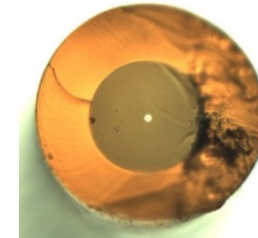
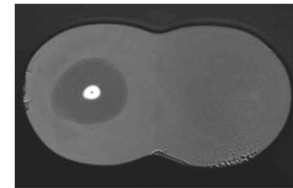
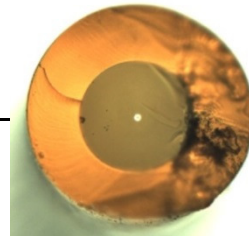
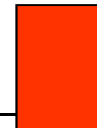
vlákno



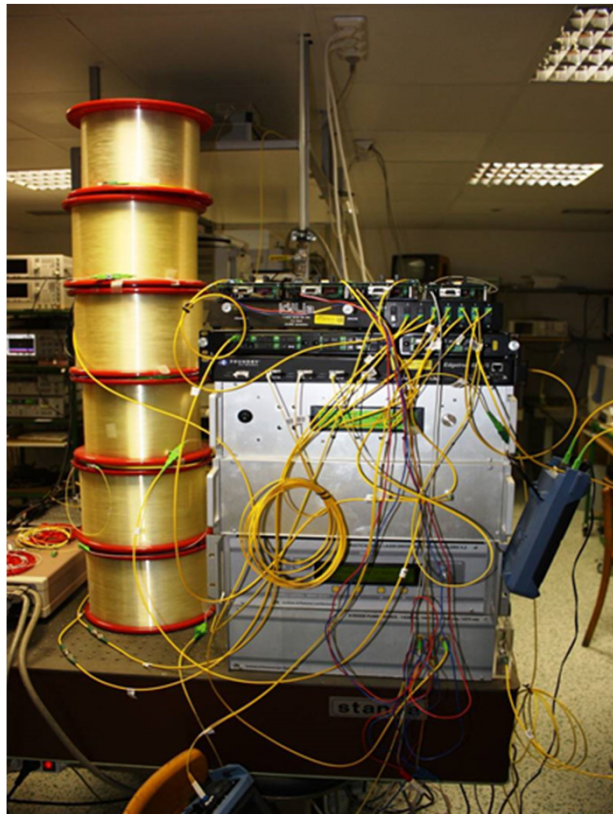
zesilovač



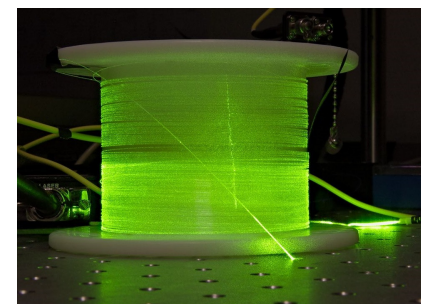
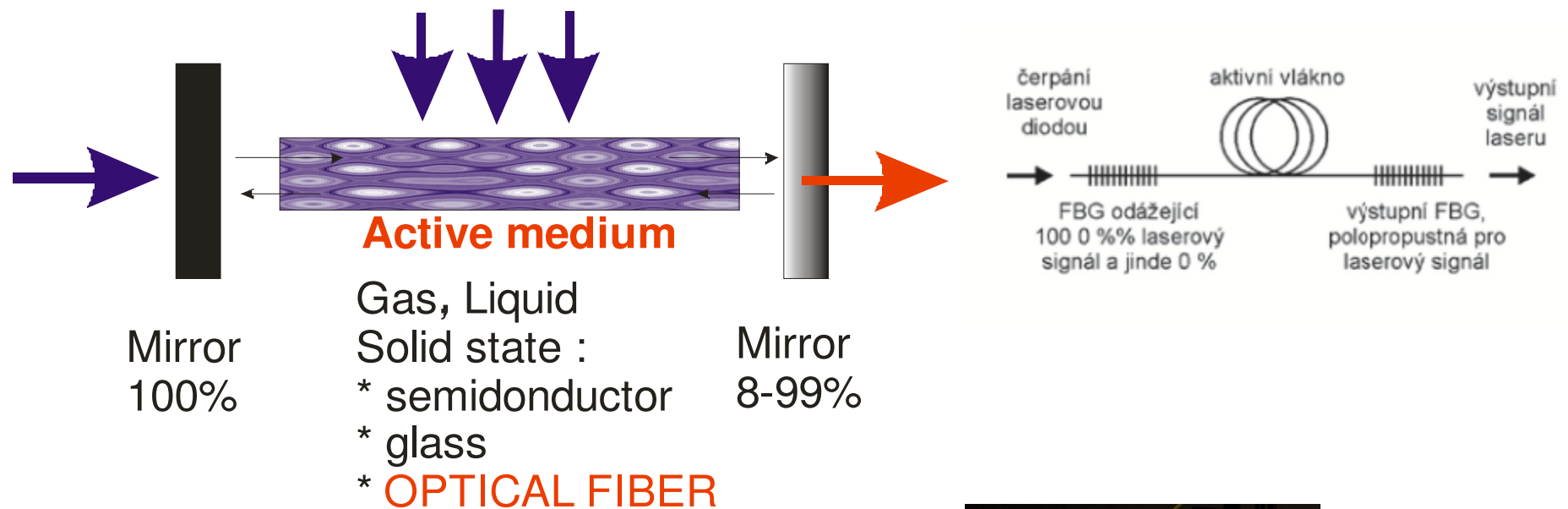
detektor



Vláknový zesilovač,
laser



Silica specialty optical fibers for fiber lasers and amplifiers



Er³⁺

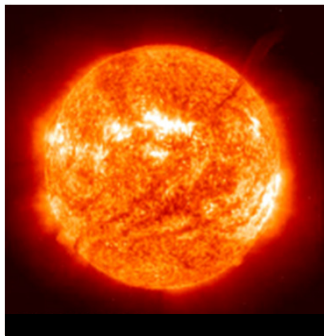
[C.J. Koester, E. Snitzer, Appl.Opt. (3) 1964, 1182] , [S.B. Poole, J.Lightwave Tech. LT-4 (1986), 870], [E.Desurvire, J.Lightwave Tech. LT-7 (1987), 835]

Fiber lasers **mW** → **kW**

- * **high conversion efficiency** (fiber lasers ~70-90%) - savings
- * **high quality beam** (nearly Gaussian, low divergency)
- * **high brightness** (high concentration of power)
- * **good thermal management** (cooling)
- * effective pumping
- * tunability
- * compactness
- * size (long resonator in small space)

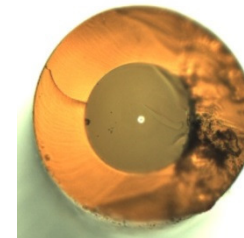


[IPG]



sun
fiber laser

63 MW/m²
12.7 GW/m²

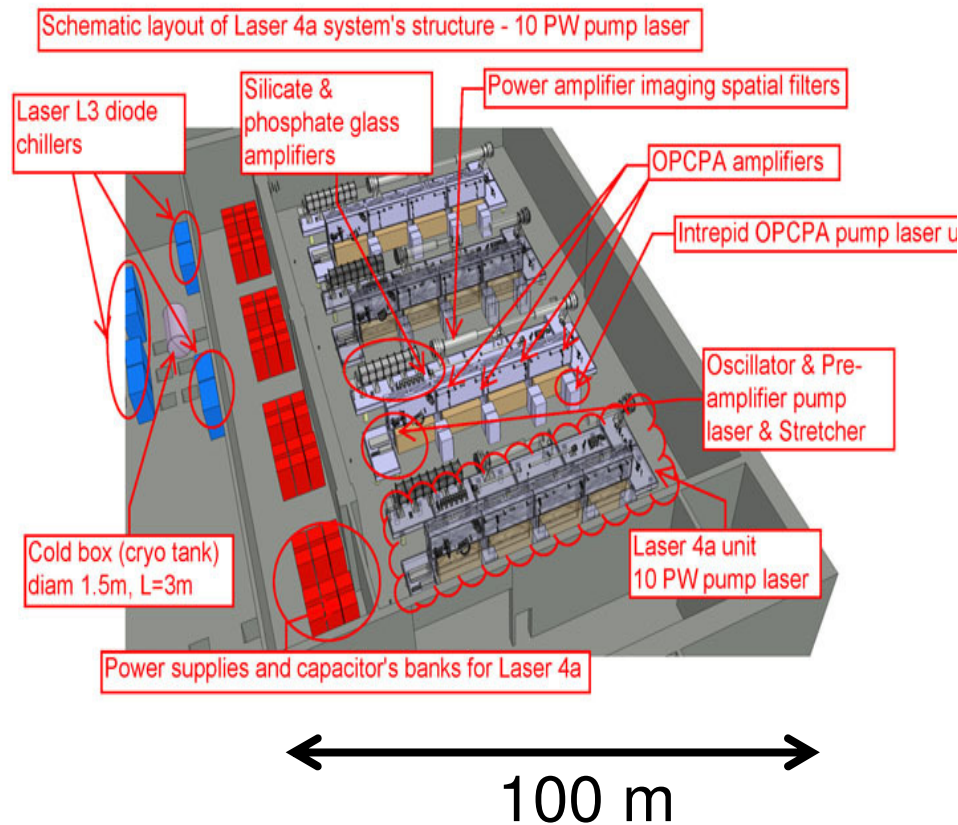


Fiber lasers vers. solid state lasers (SSL)

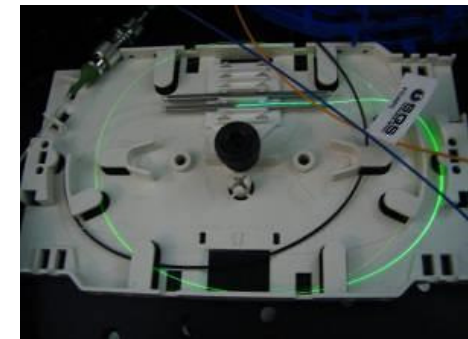
- **High brightness + flexibility**

fs pulses **5 PW** / 25x25 cm
ELI Beamlines [10^{15} W/ μm^2]

CW **40- 100 kW** / 10 μm^2
IPG Photonics [10^{15} W/ μm^2]



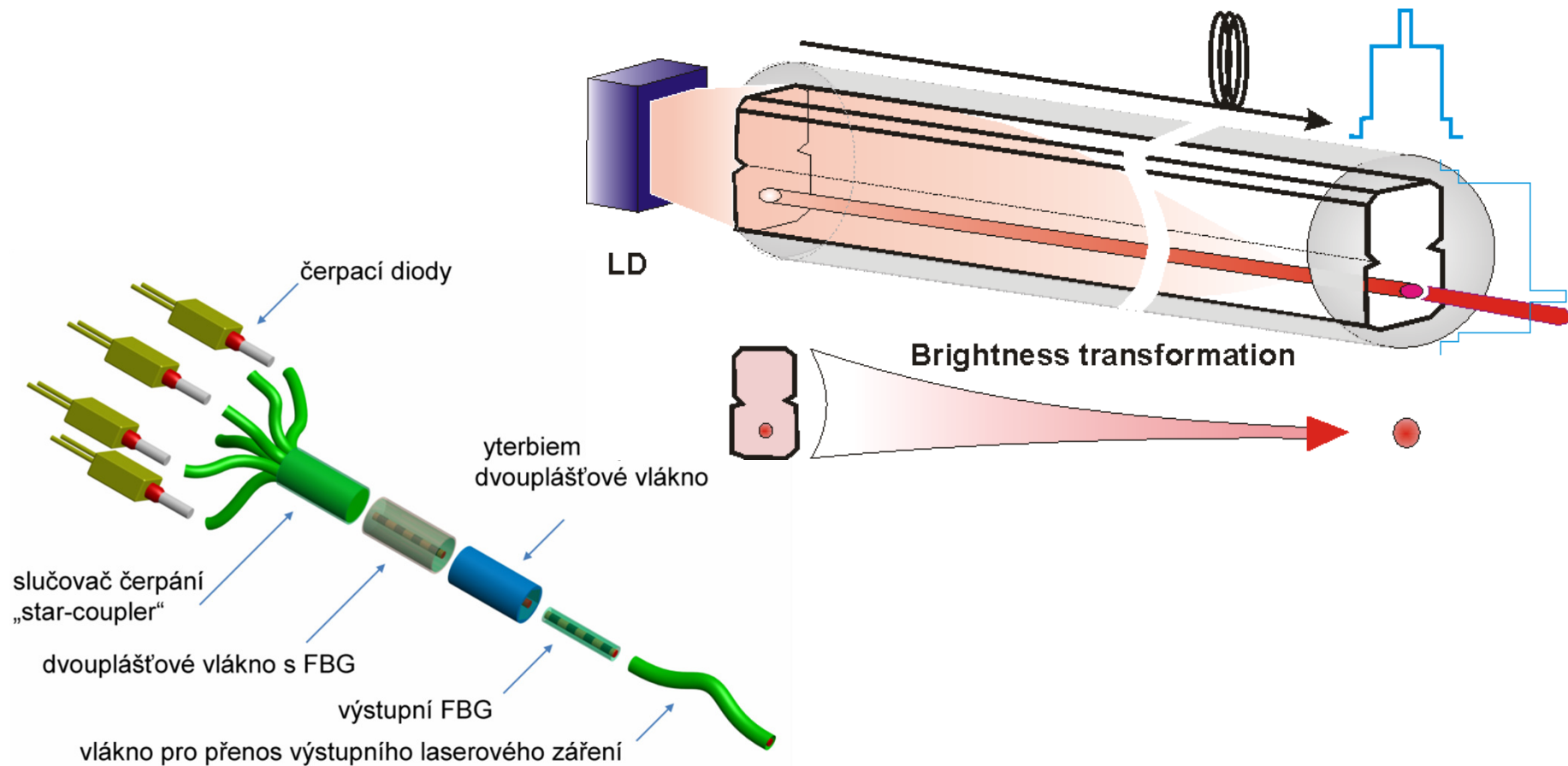
1 m



0.1 m

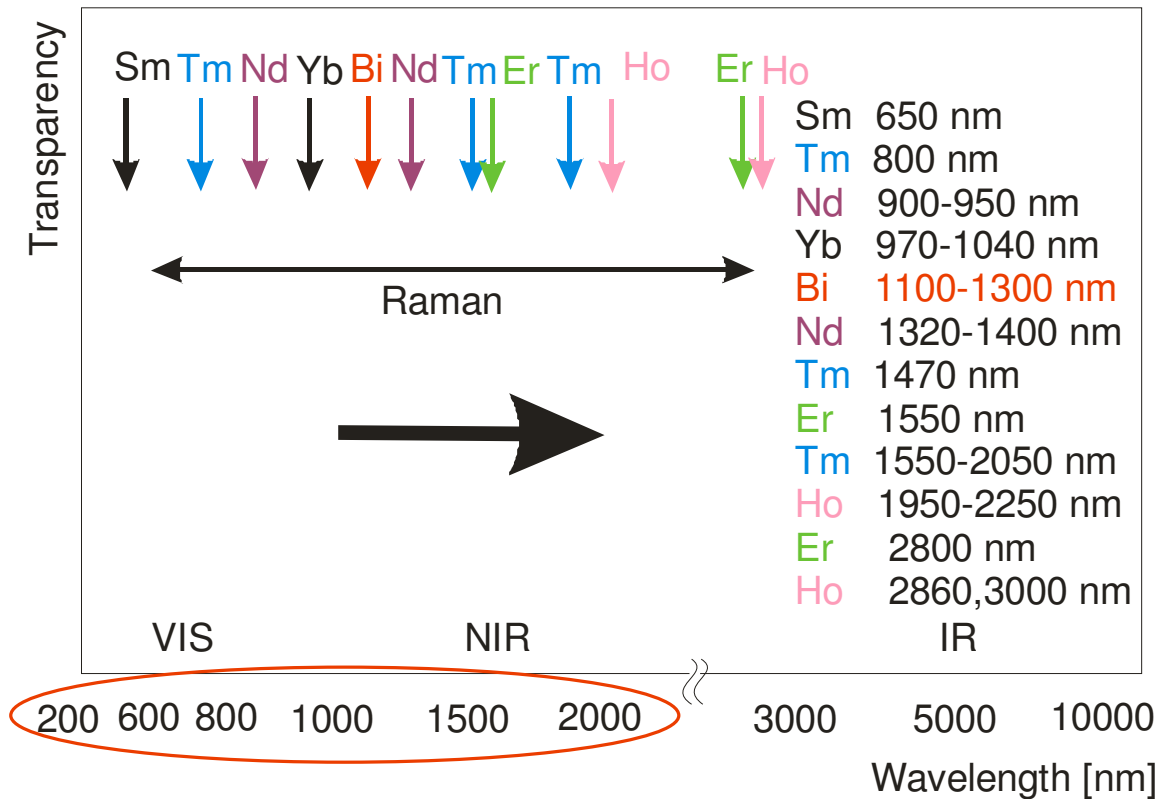
Silica (VIS-NIR) specialty optical fibers for fiber lasers and amplifiers

DC structures, beam combining ..



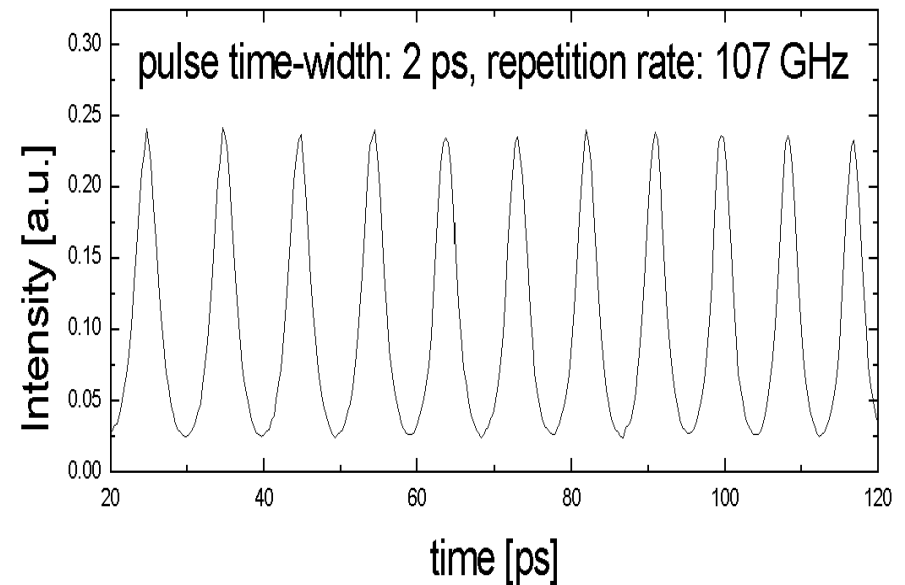
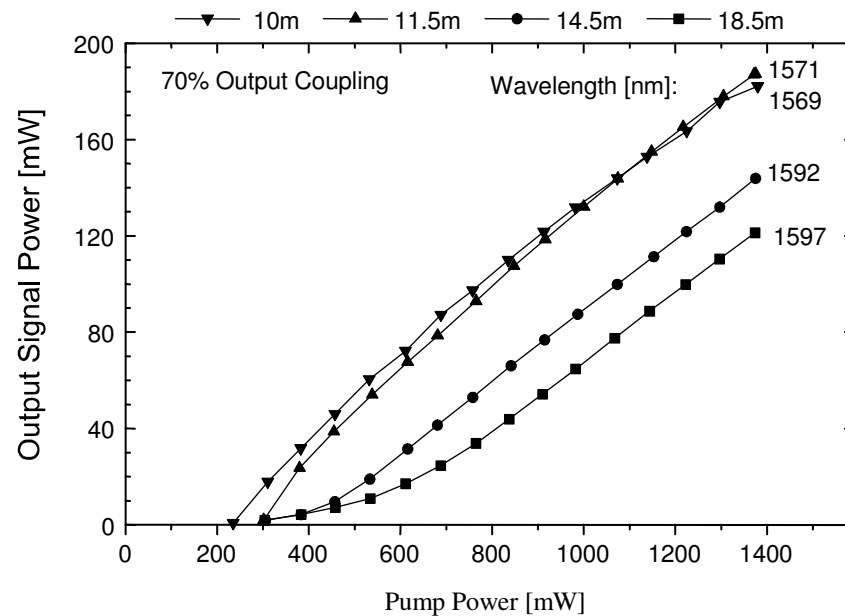
Silica (VIS-NIR) specialty optical fibers for fiber lasers and amplifiers

Dopants



Dopant combination : effective pumping due to energy transfer
 High-power lasers : **Er (1.5 um), Yb (1.1 um), Tm (1,9 um)**

Er/Yb fiber for soliton laser at 1 550 nm



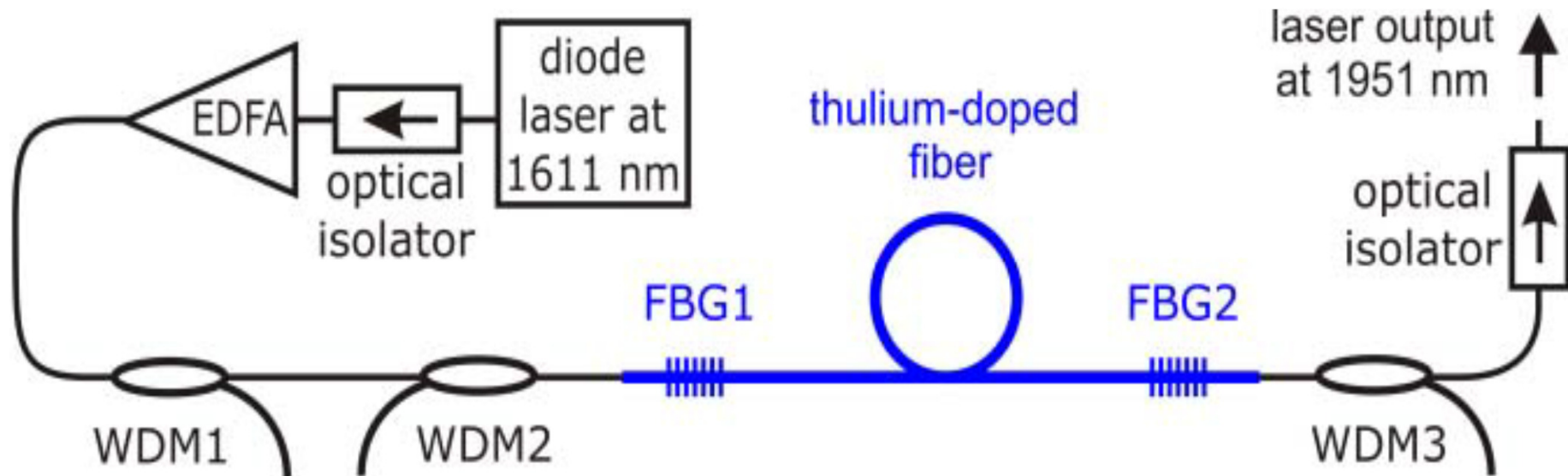
Er³⁺/Yb³⁺ : 1000/10 000 ppm, Al₂O₃-SiO₂

[Kasik, V. Matejec, J. Kanka, P. Honzatko : Pure and Appl. Opt. 7 (1998) 457-465]

[I. Kasik, V. Matejec, M. Pospisilova, J. Kanka, J. Hora : Proc. SPIE 2777 (1995) 71-79]

Monolithic Tm fiber laser at 1951 nm

Eye-safe spectral region

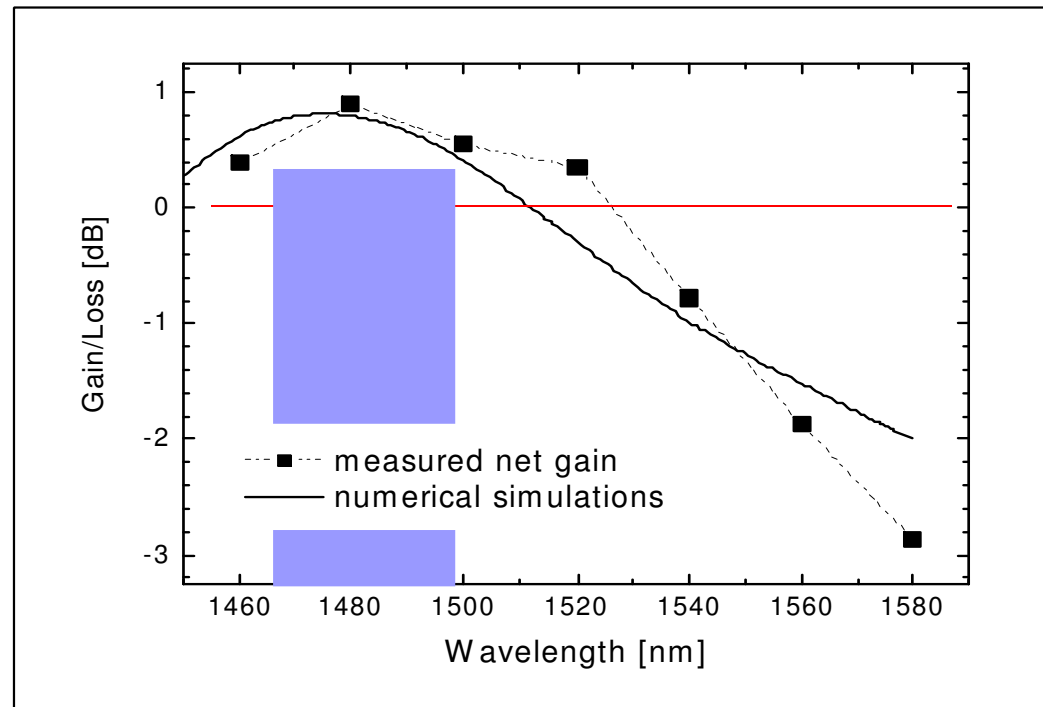
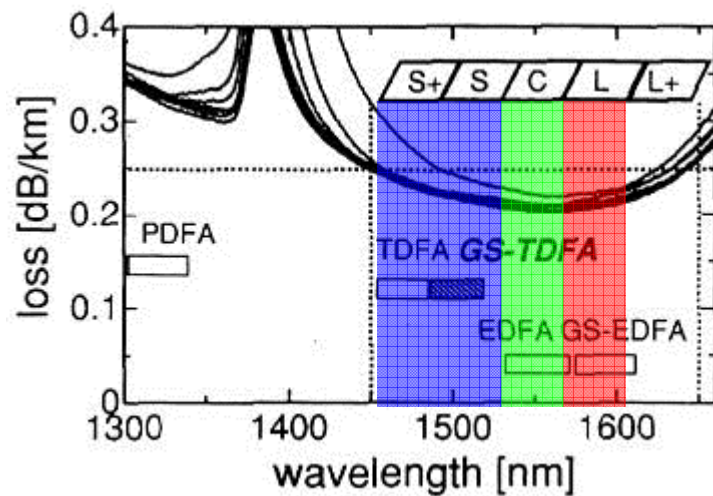


* 1000 ppm Tm³⁺, 11mol% Al₂O₃, 0 mol% P₂O₅ or GeO₂,

* **deep-UV inscription of FBG**

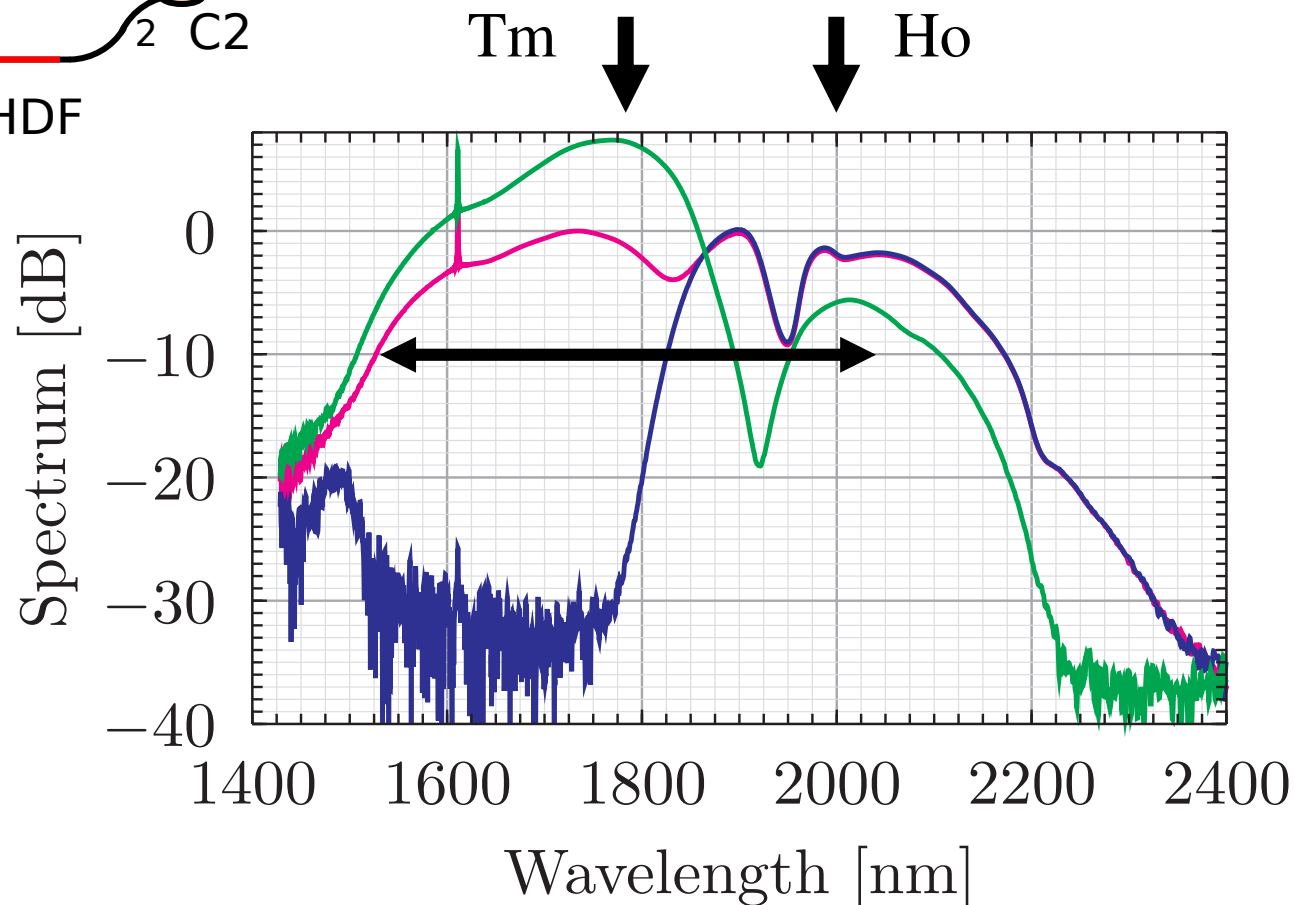
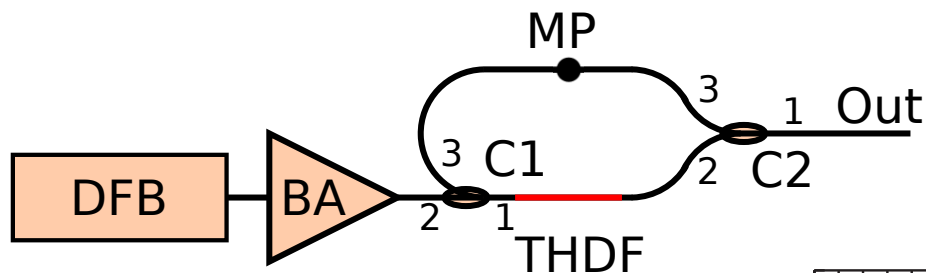
[P.Peterka, Photonic Technol Lett, 25, 2013, 1623]

Tm fiber for amplifier at 1470 nm



[P.Peterka, Opt. & Quantum El., 36 2004, 201], [W.Blanc, Proc. SPIE 6180, 2006, 61800V.1],
[P.Peterka, Optical Materials 30 (2007) 174]

Tm/Ho fiber for ASE (1550-2050 nm) source

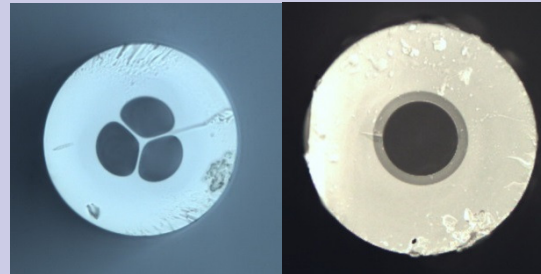


1800 ppm Tm^{3+} /
360 ppm Ho^{3+}

[P.Honzatko, Optics letters 39 (2014) 3650-3653]

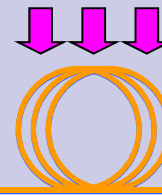
Optical fiber sensors

Source



Detector

Continuous monitoring of (bio)chemicals and their concentration.



Suitable for :

- remote sensing
- distributed sensing
- flammable or explosives
- in high-voltage areas
- human body

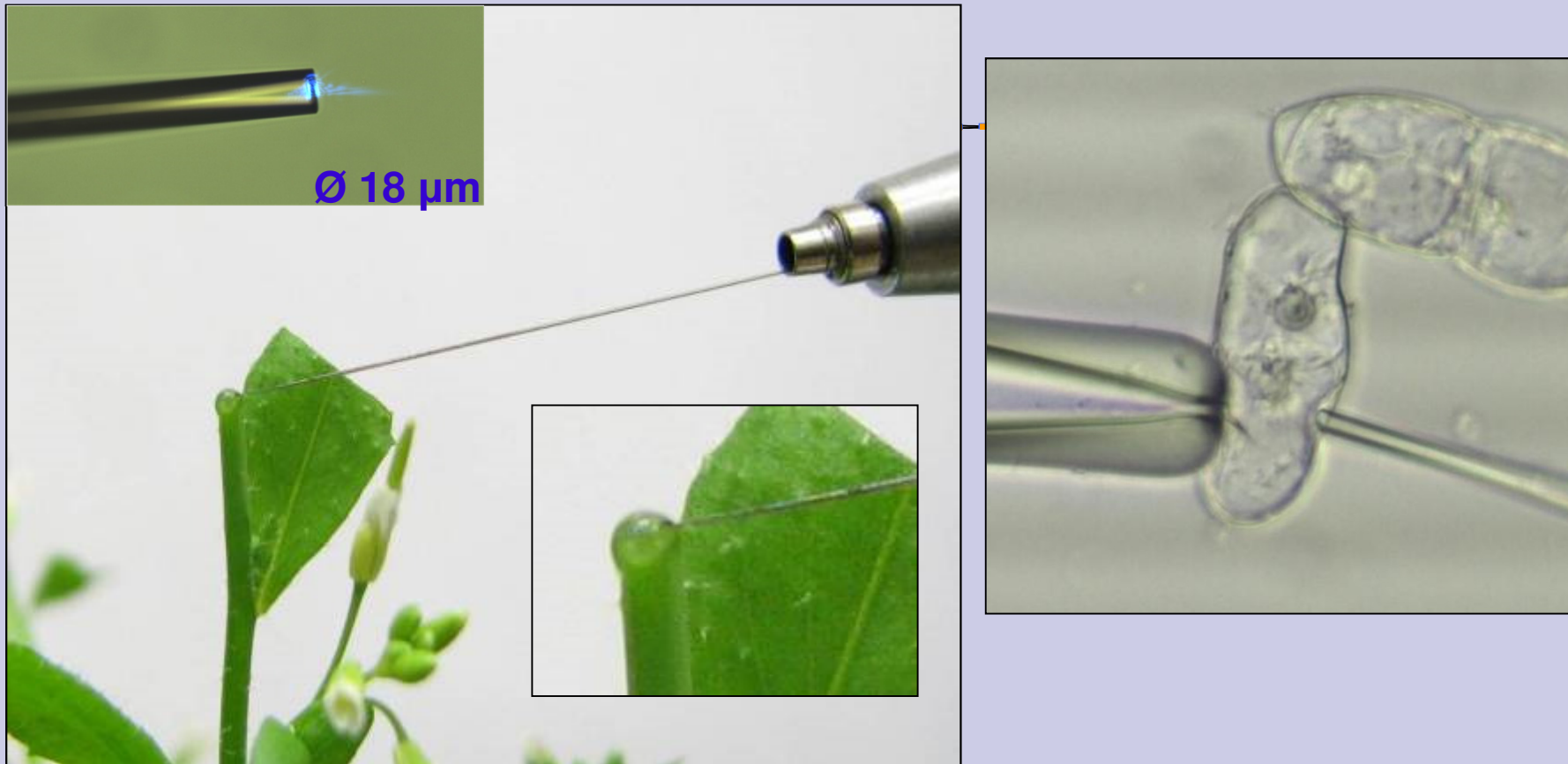
Source

Detector

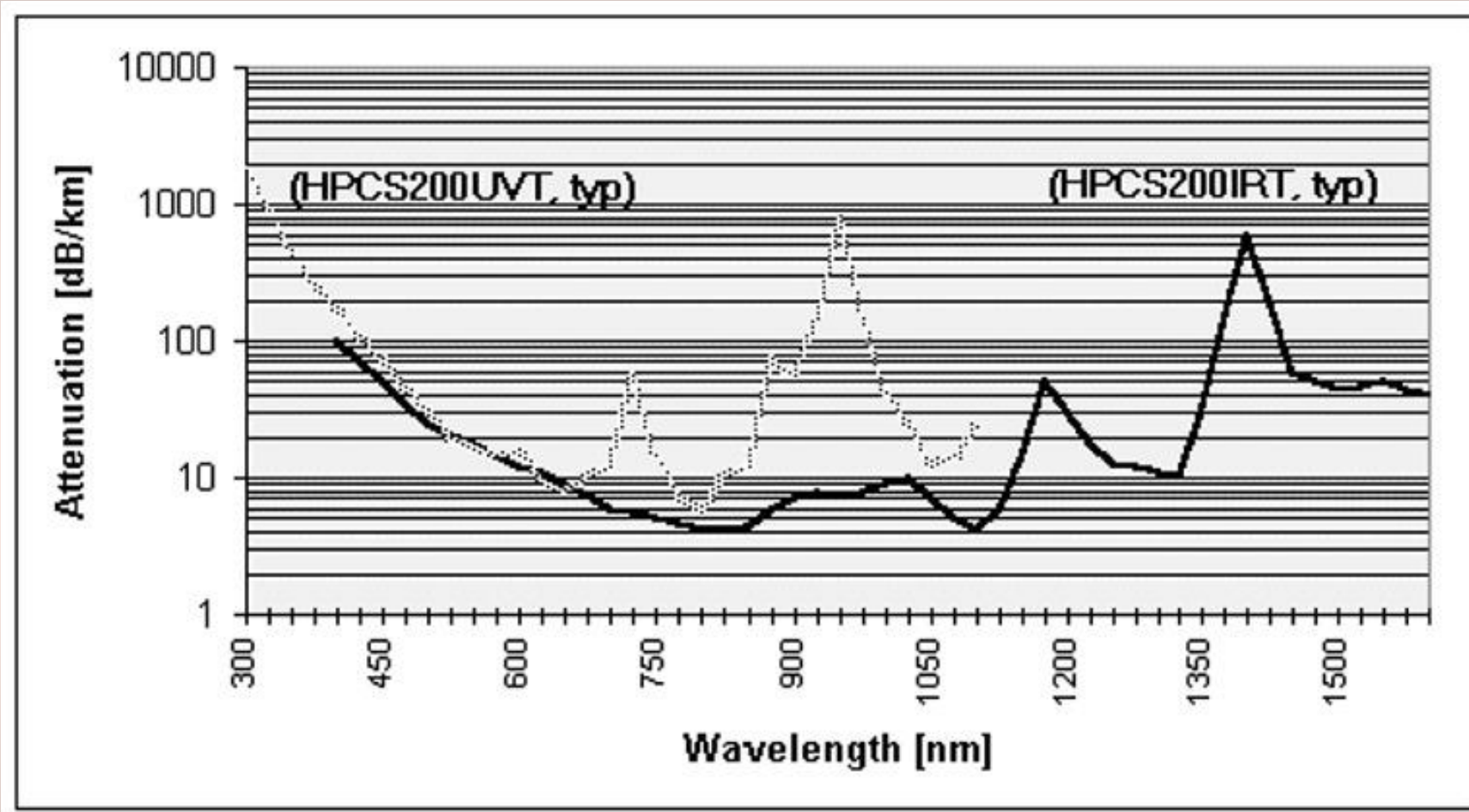


Optical fiber sensors

In vivo detection of pH in small samples $\sim \mu\text{L}$



OPTICAL FIBERS – Materials - UV



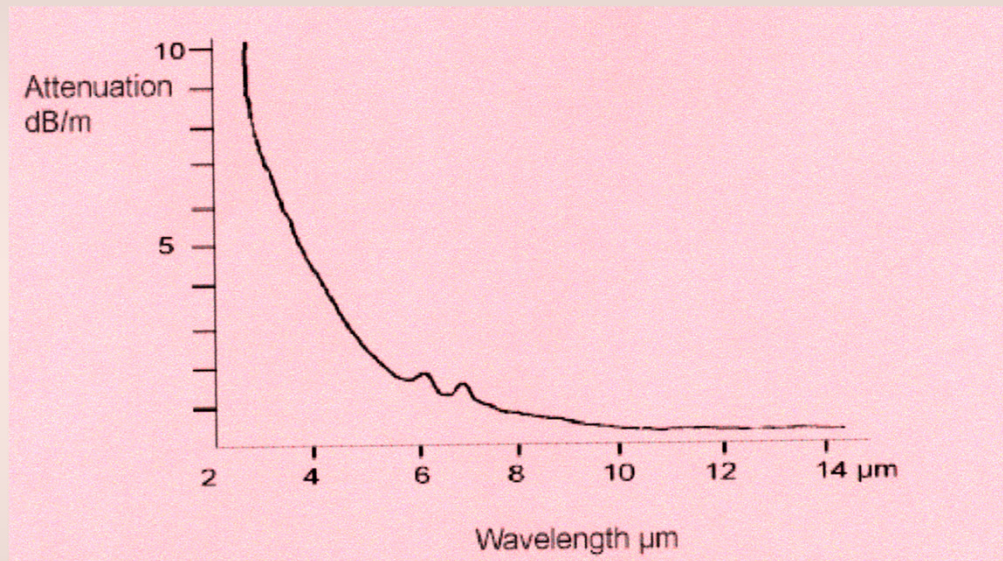
- silica fibers - SUPRASIL $n_{200 \text{ nm}} = 1.55$ [[ceramoptec.de](#), [OceanO](#), [IPE ...](#)]
- planar silica, crystalline CaF_2 (MgF_2) – [[edmundoptics](#), [technicalglass ...](#)]

OPTICAL FIBERS – VIS/NIR, IR

Silica $n_{633} = 1.457$ & doped silica $n_{633} = 1.45-1.50$ [[corning](#), [lucent](#), [ocean_o](#), [IPE](#)]

Glass (silicate - Simax, Vycor, Pyrex) $n_{588} = 1.5-1.95$ [[schott](#), [LiFaTec.de](#), [IPE...](#)]

Plastic $n_{588} = 1.5-1.6$ [[mitsubishi.com](#), [luceat.it](#), [unlimited-inc.com...](#)]



- fluoride glasses [[univ-rennes1.fr ...](#)] (up to ~4 μm)
- **sapphire [CRYTUR] (up to ~4 μm)**
- silver-halides $\text{AgCl}_x\text{Br}_{1-x}$ (up to 15 μm)
- chalcogenides (Se, As_2S_3 , As_2Se_3 ...) [[oxford-electronics](#), [orc.soton.ac.uk](#)] (< 20 μm)
- refractive indexes $_{2-20\mu\text{m}} \sim 2 - 2.5 \gg$ silicate glasses [[LiFaTec](#)]

SUMMARY

1. **Fiber technology : preparation of structures of high preciseness from materials of ultra-high purity (impurities in ppbs only).**
2. **Fiber preparation in two steps : preform preparation and fiber drawing. (M)CVD technique (preform) makes possible to prepare multilayered tailored structures of suitable level of purity.**
3. **Fibers lasers : opportunity !!**
4. **Research of optical fibers (CR) :**

UFE

References

- **J. M. Senior** : *Optical fiber communications - Principle and practise*, Pearson Education Limited, Harlow, England, 2009.
- **A. Mendez, F.T. Morse** : *Specialty optical fibers handbook*, Elsevier Science & Technol, USA, 2006.
- **J. Schrofel, K. Novotný** : *Optické vlnovody*, SNTL, 1986
- **Saaleh**, *Fotonika* (1 - 4), Matfyzpres

- **S. R. Nagel, J. B. McChesney, K. L. Walker** : An overview of the **MCVD** process and performance, *IEEE J. Quantum Electron.* QE-18 (1982) 459-477

- **Peterka - Vlákňové lasery**
- *Československý časopis pro fyziku* 1/2010, 4-5/2010, 1/2011
- *Jemná mechanika a optika* (2015)
- *Sdělovací technika* 3/2011